

KAF-09000

3056 (H) x 3056 (V) Full Frame CCD Image Sensor

Description

Combining high resolution with outstanding sensitivity, the KAF-09000 image sensor has been specifically designed to meet the needs of next-generation low cost digital radiography and scientific imaging systems. The high sensitivity available from 12-micron square pixels combines with a low noise architecture to allow system designers to improve overall image quality, or to relax system tolerances to achieve lower cost. The excellent uniformity of the KAF-09000 image sensor improves overall image integrity by simplifying image corrections, while integrated anti-blooming protection prevents image bleed from over-exposure in bright areas of the image. To simplify device integration, the KAF-09000 image sensor uses the same pin-out and package as the KAF-16801 image sensor.

The sensor utilizes the TRUESENSE Transparent Gate Electrode to improve sensitivity compared to the use of a standard front-side illuminated polysilicon electrode.

Table 1. GENERAL SPECIFICATIONS

Parameter	Typical Value
Architecture	Full Frame CCD [Square Pixels]
Total Number of Pixels	3103 (H) x 3086 (V) = 9.6 Mp
Number of Effective Pixels	3085 (H) x 3085 (V) = 9.5 Mp
Number of Active Pixels	3056 (H) x 3056 (V) = 9.3 Mp
Pixel Size	12 μm (H) x 12 μm (V)
Active Image Size	36.7 mm (H) x 36.7 mm (V) 51.9 mm diagonal, 645 1.3x optical format
Aspect Ratio	Square
Horizontal Outputs	1
Saturation Signal	110 ke ⁻
Output Sensitivity	24 $\mu\text{V}/\text{e}^-$
Quantum Efficiency (550 nm)	64%
Responsivity (550 nm)	2595 ke/ $\mu\text{J}/\text{cm}^2$ 62.3 V/ $\mu\text{J}/\text{cm}^2$
Read Noise (f = 3 MHz)	7 e ⁻
Dark Signal (T = 25°C)	5 e/pix/sec
Dark Current Doubling Temperature	7°C
Linear Dynamic Range (f = 4 MHz)	84 dB
Blooming Protection (4 ms exposure time)	> 100 X saturation exposure
Maximum Data Rate	10 MHz
Package	CERDIP, (sidebraced pins, CuW)
Cover Glass	AR coated 2 sides Taped Clear

NOTE: Parameters above are specified at T = 25°C unless otherwise noted.



ON Semiconductor®

www.onsemi.com

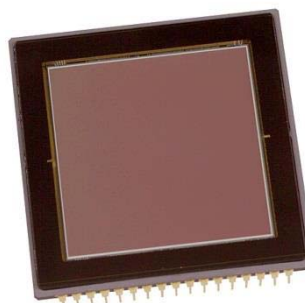


Figure 1. KAF-09000 CCD Image Sensor

Features

- TRUESENSE Transparent Gate Electrode for High Sensitivity
- Large Pixel Size
- Large Image Area
- High Quantum Efficiency
- Low Noise Architecture
- Broad Dynamic Range

Applications

- Medical
- Scientific

ORDERING INFORMATION

See detailed ordering and shipping information on page 2 of this data sheet.

KAF-09000

ORDERING INFORMATION

Table 2. ORDERING INFORMATION

Part Number	Description	Marking Code
KAF-09000-ABA-DP-BA	Monochrome, Microlens, CERDIP Package, (sidebrazed, CuW), Taped clear coverglass, Standard grade	KAF-09000-ABA [Serial Number]
KAF-09000-ABA-DP-AE	Monochrome, Microlens, CERDIP Package, (sidebrazed, CuW), Taped clear coverglass, Engineering sample	
KAF-09000-ABA-DD-BA	Monochrome, Microlens, CERDIP Package, (sidebrazed, CuW), AR coated 2 sides, Standard grade	
KAF-09000-ABA-DD-AE	Monochrome, Microlens, CERDIP Package, (sidebrazed, CuW), AR coated 2 sides, Engineering sample	

See the ON Semiconductor *Device Nomenclature* document (TND310/D) for a full description of the naming convention used for image sensors. For reference documentation, including information on evaluation kits, please visit our web site at www.onsemi.com.

DEVICE DESCRIPTION

Architecture

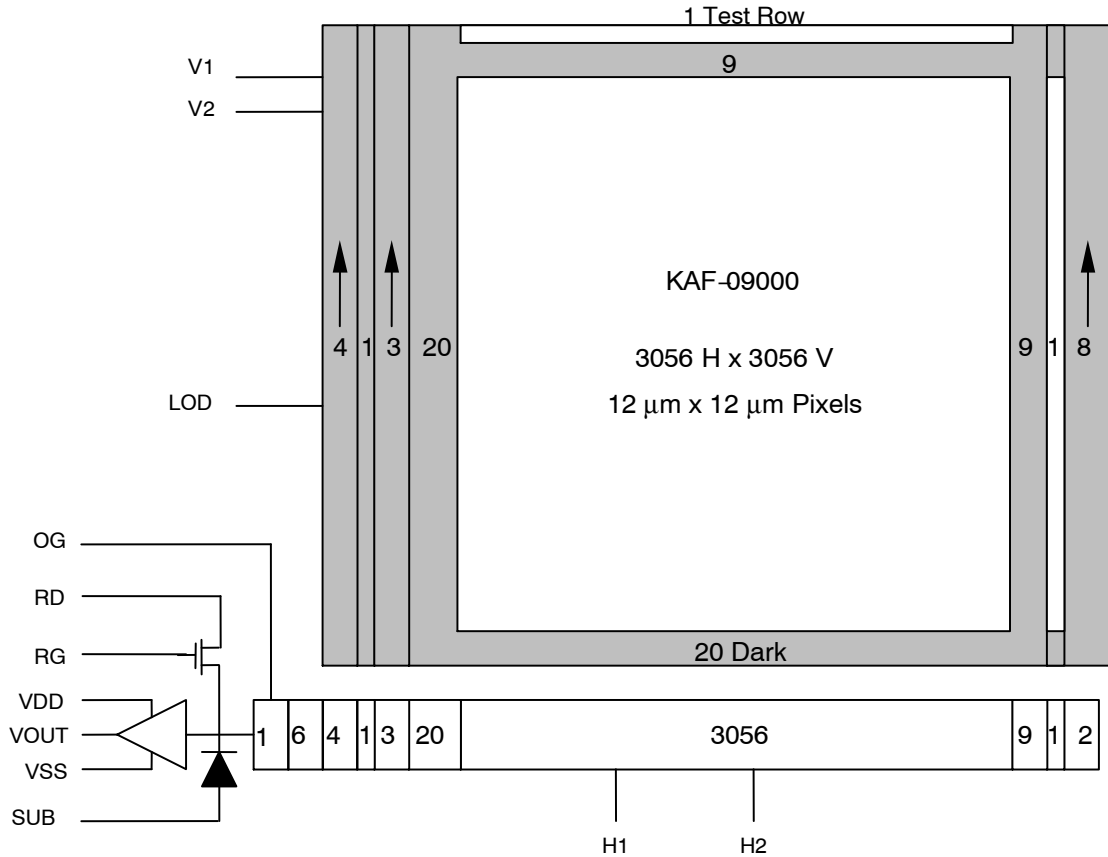


Figure 2. Block Diagram

Dark Reference Pixels

The periphery of the device is surrounded with a border of light shielded pixels creating a dark region. Within this dark region, there are 20 leading dark pixels on every line as well as 20 full dark lines at the start and 9 full dark lines at the end of every frame. Under normal circumstances, these pixels do not respond to light and may be used as a dark reference.

Dummy Pixels

Within each horizontal shift register there are 14 leading pixels and 3 trailing pixels. These are designated as dummy pixels and should not be used to determine a dark reference level.

Image Acquisition

An electronic representation of an image is formed when incident photons falling on the sensor plane create electron-hole pairs within the device. These photon-induced electrons are collected locally by the

formation of potential wells at each pixel site. The number of electrons collected is linearly dependent on light level and exposure time and non-linearly dependent on wavelength. When the pixel's capacity is reached, excess electrons are discharged into the lateral overflow drain to prevent crosstalk or 'blooming'. During the integration period, the V1 and V2 register clocks are held at a constant (low) level.

Charge Transport

The integrated charge from each pixel is transported to the output using a two-step process. Each line (row) of charge is first transported from the vertical CCDs to a horizontal CCD register using the V1 and V2 register clocks. The horizontal CCD is presented a new line on the falling edge of V2 while H1 is held high. The horizontal CCDs then transport each line, pixel by pixel, to the output structure by alternately clocking the H1 and H2 pins in a complementary fashion.

HORIZONTAL REGISTER

Output Structure

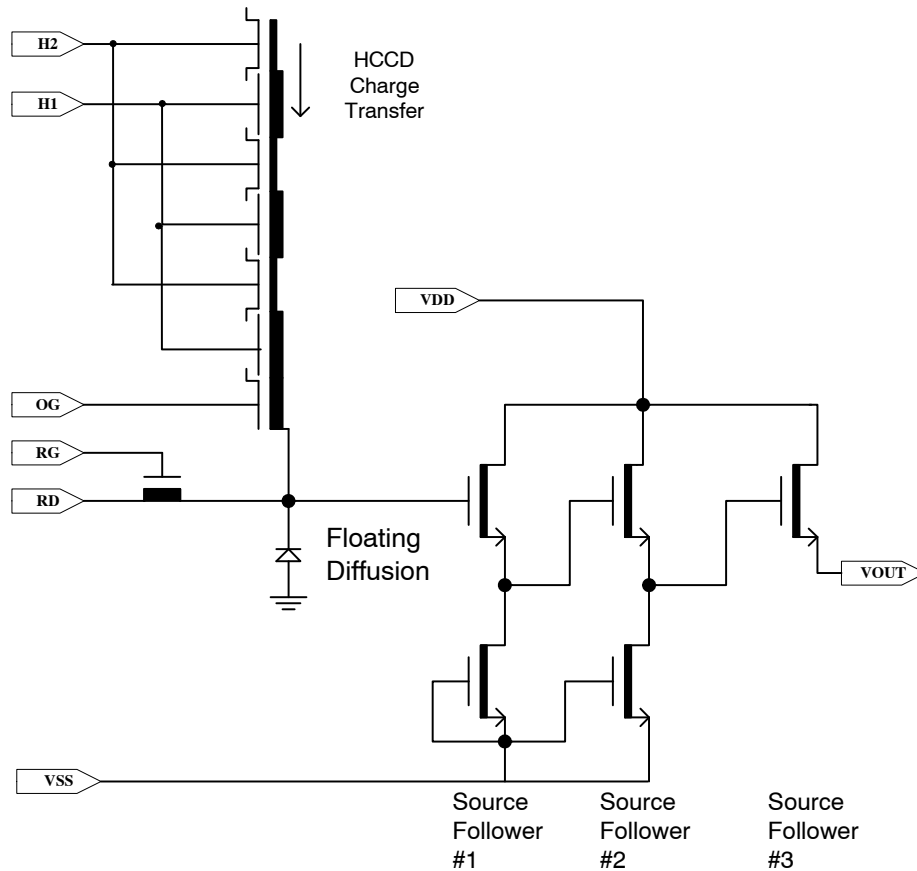
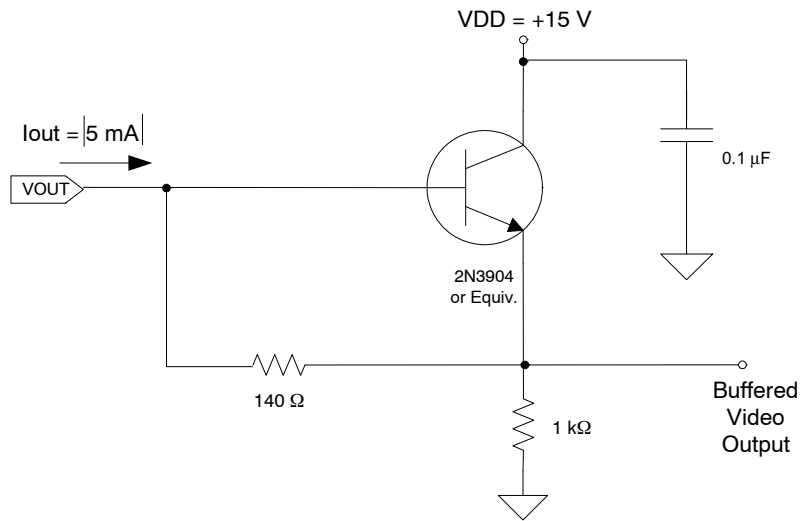


Figure 3. Output Architecture (Left or Right)

The output consists of a floating diffusion capacitance connected to a three-stage source follower. Charge presented to the floating diffusion (FD) is converted into a voltage and is current amplified in order to drive off-chip loads. The resulting voltage change seen at the output is linearly related to the amount of charge placed on the FD. Once the signal has been sampled by the system electronics,

the reset gate (RG) is clocked to remove the signal and FD is reset to the potential applied by reset drain (RD). Increased signal at the floating diffusion reduces the voltage seen at the output pin. To activate the output structure, an off-chip current source must be added to the VOUT pin of the device. See Figure 4.

Output Load

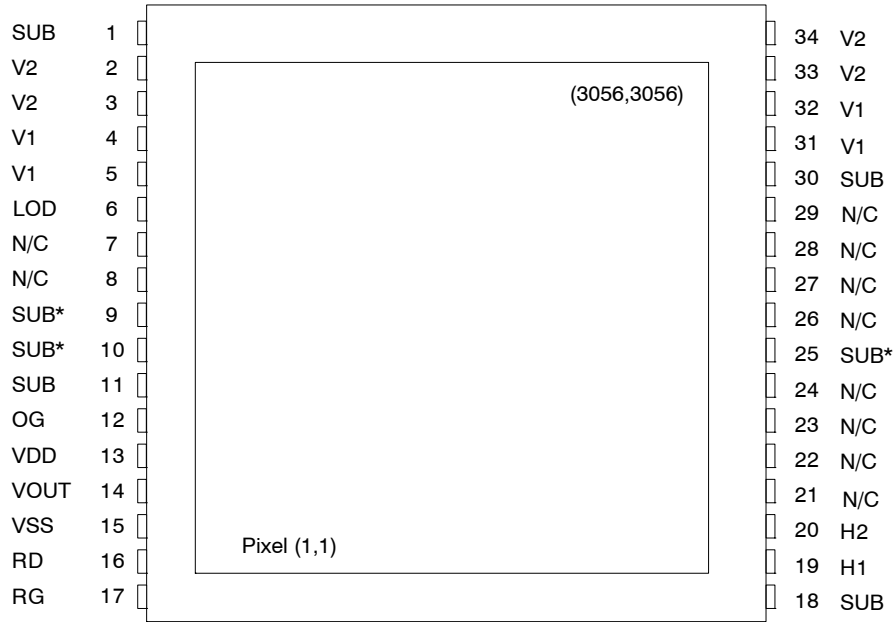


Note: Component values may be revised based on operating conditions and other design considerations.

Figure 4. Recommended Output Structure Load Diagram

PHYSICAL DESCRIPTION

Pin Description and Device Orientation



- Notes: 1. Pins with the same name are to be tied together on the circuit board and have the same timing.
 2. Unlike the KAF-16801, pins 9, 10, and, 25 are internally connected to SUB. They may be connected to SUB on the printed circuit board or may be left floating.

Figure 5. Pinout Diagram

Table 3. PIN DESCRIPTION

Pin	Name	Description
1	SUB	Substrate
2	V2	Vertical CCD Clock - Phase 2
3	V2	Vertical CCD Clock - Phase 2
4	V1	Vertical CCD Clock - Phase 1
5	V1	Vertical CCD Clock - Phase 1
6	LOD	Anti Blooming Drain
7	N/C	No Connection
8	N/C	No Connection
9	SUB*	No Connection
10	SUB*	No Connection
11	SUB	Substrate
12	OG	Output Gate
13	VDD	Output Amplifier Supply
14	VOUT	Video Output
15	VSS	Output Amplifier Return
16	RD	Reset Drain
17	RG	Reset Gate

18	SUB	Substrate
19	H1	Horizontal Phase 1
20	H2	Horizontal Phase 2
21	N/C	No Connection
22	N/C	No Connection
23	N/C	No Connection
24	N/C	No Connection
25	SUB*	No Connection
26	N/C	No Connection
27	N/C	No Connection
28	N/C	No Connection
29	N/C	No Connection
30	SUB	Substrate
31	V1	Vertical CCD Clock - Phase 1
32	V1	Vertical CCD Clock - Phase 1
33	V2	Vertical CCD Clock - Phase 2
34	V2	Vertical CCD Clock - Phase 2

*Unlike the KAF-16801, pins 9, 10, and, 25 are internally connected to SUB. They may be connected to SUB on the printed circuit board or must be left floating.

IMAGING PERFORMANCE

Table 4. TYPICAL OPERATIONAL CONDITIONS

Description	Condition – Unless otherwise noted	Notes
Read out time treadout	2533 ms	Includes over clock pixels
Integration time (tint)	variable	
Horizontal clock frequency	4 MHz	
Temperature	25°C	Room temperature
Mode	integrate – readout cycle	
Operation	Nominal operating voltages and timing with min. vertical pulse width $tVw = 20 \mu s$	

Table 5. SPECIFICATIONS

Description	Symbol	Min.	Nom.	Max.	Units	Notes	Verification Plan
Saturation Signal	Ne^-_{sat}	95k	110k		e^-		die ¹¹
Quantum Efficiency (550 nm)	QE		64		%	1	design ¹²
Photo Response Non-Linearity	PRNL		1		%	2	design ¹²
Photo Response Non-Uniformity	PRNU		0.5	2.5	%	3	die ¹¹
Integration Dark Signal	Vdark, int		5	20	e/pix/sec	4	die ¹¹
			0.6	2.8	pA/cm ²		
Read out Dark Signal	Vdark, read		80	320	electrons	5	die ¹¹
Dark Signal Non-Uniformity	DSNU			20	e/pix/sec	6	die ¹¹
Dark Signal Doubling Temperature	ΔT		7		°C		design ¹²
Read Noise	NR		7	14	e^-_{rms}	7	design ¹²
Linear Dynamic Range	DR		84		dB	8	design ¹²
Blooming Protection	Xab	100			x Vsat	9	design ¹²
Output Amplifier Sensitivity	V_{out}/Ne^-		24		$\mu V/e$		design ¹²
DC Offset, output amplifier	Vdc	Vrd-4	Vrd-2.0		V	10	die ¹¹
Output Amplifier Bandwidth	f_{-3dB}		88		MHz		design ¹²
Output Impedance, Amplifier	ROUT		150	250	Ω		die ¹¹

- Increasing output load currents to improve bandwidth will decrease these values.
- Worst case deviation from straight line fit, between 1% and 90% of Vsat.
- One Sigma deviation of a 128 x 128 sample when CCD illuminated uniformly.
- Average of all pixels with no illumination at 25°C.
- Read out dark current depends on the read out time, primarily when the vertical CCD clocks are at their high levels. This is approximately 0.125 sec/image for nominal timing conditions, $tVw = 20 \mu s$. The read out dark current will increase as tVw is increased. The readout dark current is also dependent on the operating temperature. The specification applies to 25°C.
- Average integration dark signal of any of 32 x 32 blocks within the sensor. (each block is 128 x 128 pixels)
- Output amplifier noise only. Operating at pixel frequency up to 4 MHz, bandwidth <20 MHz, tint = 0, and no dark current shot noise.
- $20\log(V_{sat}/VN)$
- Xab is the number of times above the Vsat illumination level that the sensor will bloom by spot size doubling. The spot size is 10% of the imager height. Xab is measured at 4 ms.
- Video level offset with respect to ground.
- A parameter that is measured on every sensor during production testing.
- A parameter that is quantified during the design verification activity.

KAF-09000

TYPICAL PERFORMANCE CURVES (QE)

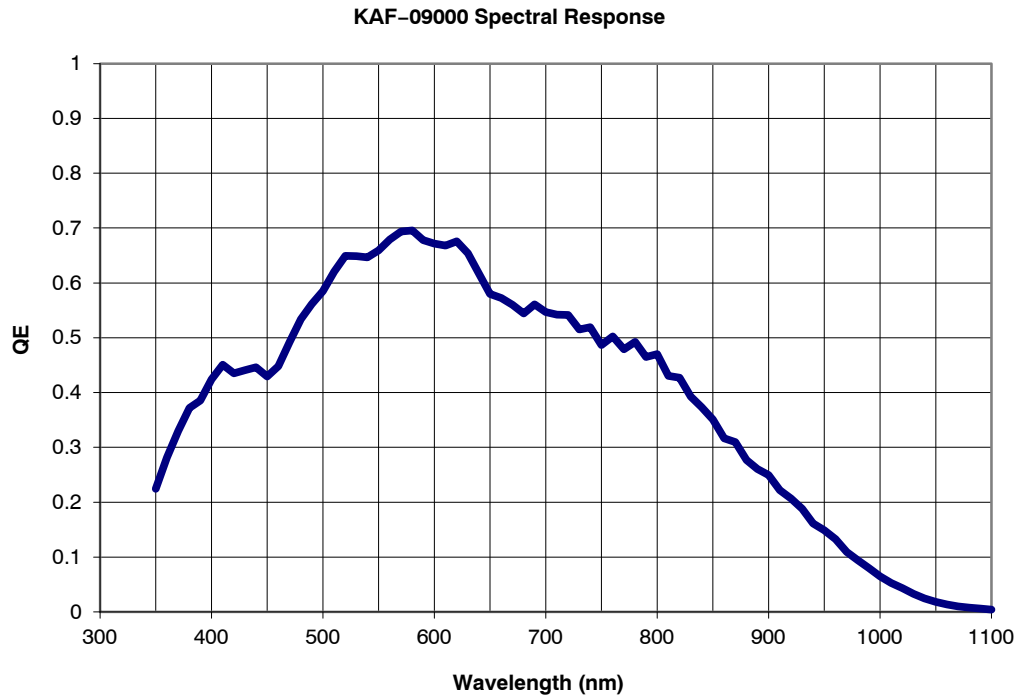


Figure 6. Typical Spectral Response

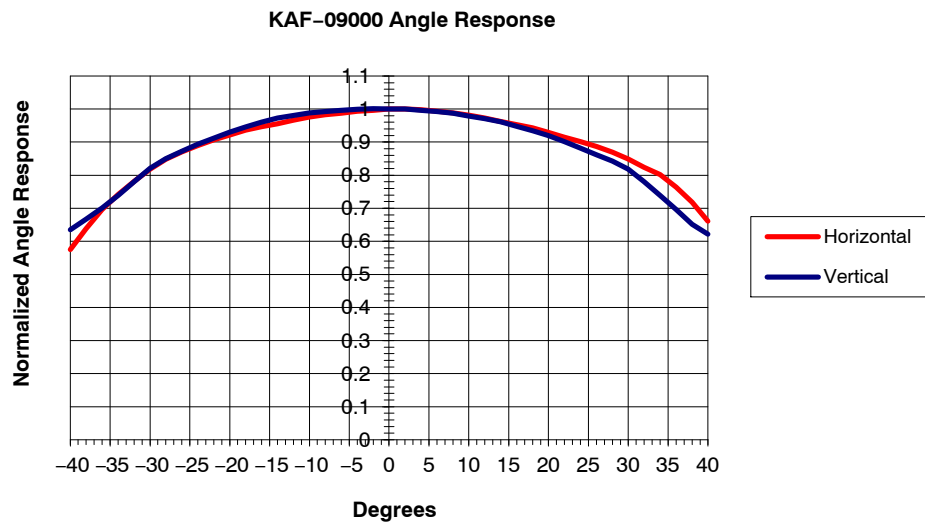


Figure 7. Typical Angle Response

KAF-09000

KAF-09000 Dark Current

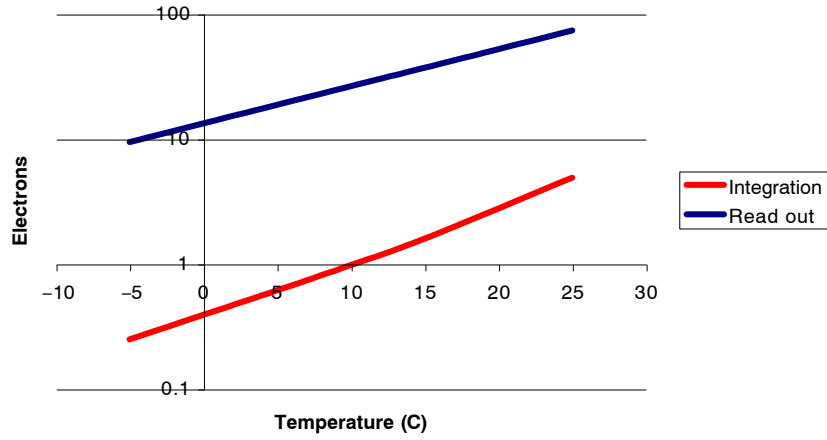


Figure 8. Dark Current

KAF-09000 Noise Floor

System noise = 6.5 electrons (10MHz bandwidth)

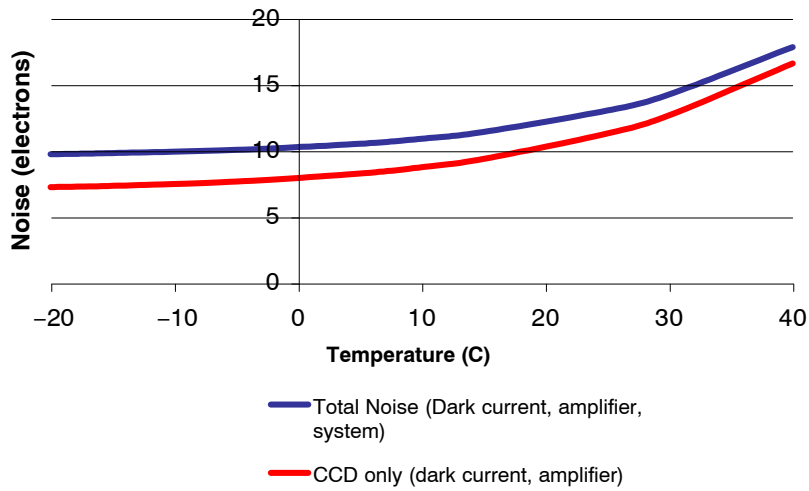


Figure 9. Noise Floor

KAF-09000

KAF-09000 Linearity

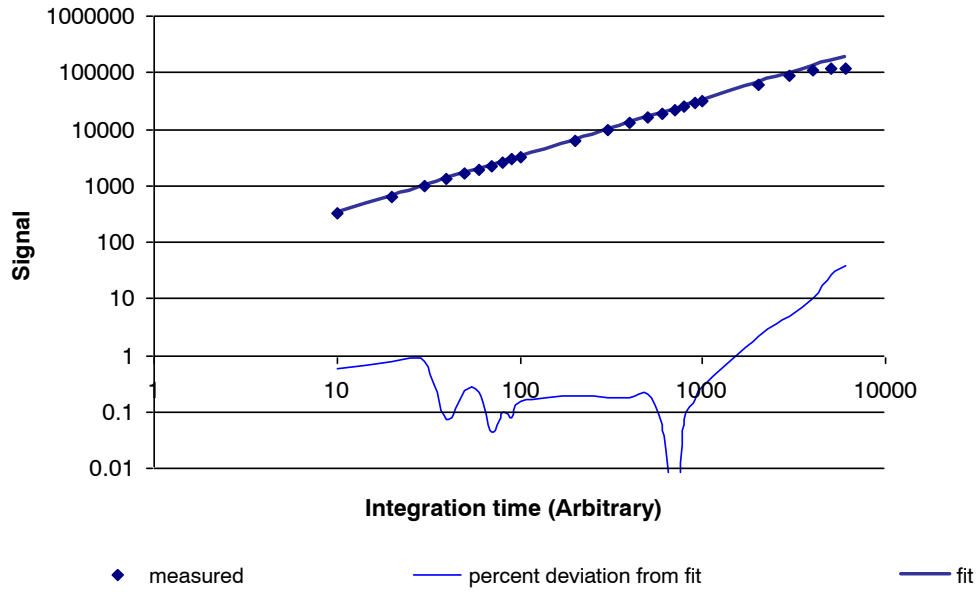


Figure 10. Linearity

DEFECT DEFINITIONS

Operating Conditions

All cosmetic tests performed at approximately 25°C.

Table 6. SPECIFICATIONS

Classification	Points	Clusters	Columns	Includes Dead Columns
Standard Grade	< 200	< 20	< 10	yes

Point Defects

Dark: A pixel, which deviates by more than 6% from neighboring pixels when illuminated to 70% of saturation

–or–

Bright: A Pixel with dark current > 3,000 e/pixel/sec at 25°C

Cluster Defect

A grouping of not more than 10 adjacent point defects

Cluster defects are separated by no less than 4 good pixels in any direction

Column Defect

A grouping of more than 10 point defects along a single column

–or–

A column containing a pixel with dark current > 15,000 e/pixel/sec (bright column)

–or–

A column that does not meet the CTE specification for all exposures less than the specified Max sat. signal level and greater than 2 ke⁻

A pixel, which loses more than 250 e⁻ under 2 ke⁻ illumination (trap defect)

Column defects are separated by no less than 4 good columns. No multiple column defects (double or more) will be permitted.

Column and cluster defects are separated by at least 4 good columns in the x direction.

OPERATION

Table 7. ABSOLUTE MAXIMUM RATINGS

Description	Symbol	Minimum	Maximum	Units	Notes
Diode Pin Voltages	V_{diode}	-0.5	+20	V	1, 2
Adjacent Gate Pin Voltages	V_{gate1}	-18	+18	V	1, 3
Isolated Gate Pin Voltages	V_{1-2}	-0.5	+20	V	4
Output Bias Current	I_{out}		-30	mA	5
LOD Diode Voltage	V_{LOD}	-0.5	-13.0	V	6
Operating Temperature	T_{OP}	-60	60	°C	7

Stresses exceeding those listed in the Maximum Ratings table may damage the device. If any of these limits are exceeded, device functionality should not be assumed, damage may occur and reliability may be affected.

1. Referenced to pin SUB
2. Includes pins: RD, VDD, VSS, VOUT.
3. Includes pins: V1, V2, H1, H2, VOG.
4. Includes pins: RG.
5. Avoid shorting output pins to ground or any low impedance source during operation. Amplifier bandwidth increases at higher currents and lower load capacitance at the expense of reduced gain (sensitivity). Operation at these values will reduce MTTF.
6. V1, H1, V2, H2, H1L, VOG, and RD are tied to 0 V.
7. Noise performance will degrade at higher temperatures due to the temperature dependence of the dark current.
8. Absolute maximum rating is defined as a level or condition that should not be exceeded at any time. If the level or condition is exceeded, the device will be degraded and may be damaged.

Power-up Sequence

The sequence chosen to perform an initial power-up is not critical for device reliability. A coordinated sequence may minimize noise and the following sequence is recommended:

1. Connect the ground pins (SUB).
2. Supply the appropriate biases and clocks to the remaining pins.

Table 8. DC BIAS OPERATING CONDITIONS

Description	Symbol	Minimum	Nominal	Maximum	Units	Maximum DC Current (mA)	Notes
Reset Drain	V_{RD}	12.8	13	13.2	V	$I_{RD} = 0.01$	
Output Amplifier Supply	V_{SS}	1.8	2.0	2.2	V	$I_{SS} = 3.0$	
Output Amplifier Return	V_{DD}	14.8	15.0	17.0	V	$I_{OUT} + I_{SS}$	
Substrate	V_{SUB}		0		V	0.01	
Output Gate	V_{OG}	0	1	2	V	0.01	
Lateral Overflow Drain	V_{LOD}	7.8	8.0	9.0	V	0.01	
Video Output Current	I_{OUT}	-3	-5	-7	mA		1

1. An output load sink must be applied to VOUT to activate output amplifier – see Figure 4.

AC Operating Conditions

Table 9. CLOCK LEVELS

Description	Symbol	Level	Minimum	Nominal	Maximum	Units	Notes
V1 Low Level	V1L	Low	-9.5	-9.0	-8.5	V	1
V1 High Level	V1H	High	2.3	2.5	2.7	V	1
V2 Low Level	V2L	Low	-9.5	-9.0	-8.5	V	1
V2 High Level	V2H	High	2.3	2.5	2.7	V	1
H1 Low Level	H1L	Low	-2.5	-2	-1.7	V	1
H1 High Level	H1H	High	7.5	8	8.2	V	1

1. All pins draw less than 10 μ A DC current. Capacitance values relative to SUB (substrate).

Table 9. CLOCK LEVELS

Description	Symbol	Level	Minimum	Nominal	Maximum	Units	Notes
H2 Low Level	H2L	Low	-2.5	-2	-1.7	V	1
H2 High Level	H2H	High	7.5	8	8.2	V	1
RG Low Level	RGL	Low	5.3	5.5	5.7	V	1
RG High Level	RGH	High	11.2	11	10.8	V	1

1. All pins draw less than 10 μ A DC current. Capacitance values relative to SUB (substrate).

Capacitance Equivalent Circuit

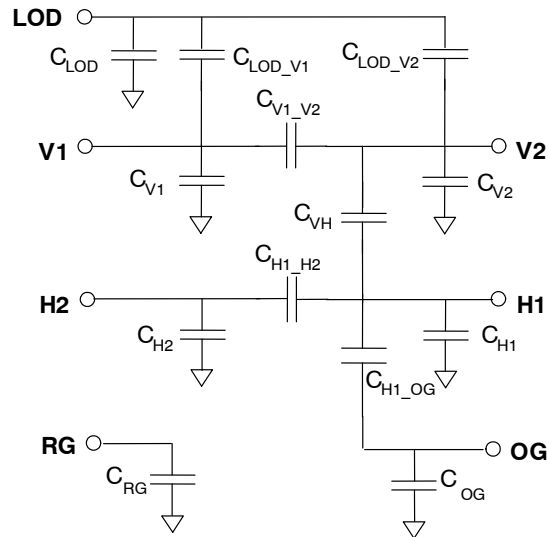


Figure 11. Equivalent Circuit Model

Table 10.

Description	Label	Value	Unit
LOD-Sub Capacitance	C_{LOD}	6.5	nF
LOD-V1 Capacitance	C_{LOD_V1}	36	nF
LOD-V2 Capacitance	C_{LOD_V2}	36	nF
V1-V2 Capacitance	C_{V1_V2}	80	nF
V1-Sub Capacitance	C_{V1_SUB}	250	nF
V2-Sub Capacitance	C_{V2_SUB}	250	nF
V2-H1 Capacitance	C_{VH}	36	pF
H1-H2 Capacitance	C_{H1_H2}	75	pF
H1-Sub Capacitance	C_{H1_Sub}	500	pF
H2-Sub Capacitance	C_{H2_Sub}	300	pF
OG-Sub Capacitance	C_{OG_Sub}	5	pF
RG-Sub Capacitance	C_{RG_Sub}	13	pF

TIMING

Table 11. REQUIREMENTS AND CHARACTERISTICS

Description	Symbol	Minimum	Nominal	Maximum	Units	Notes
H1, H2 Clock Frequency	f_H		4	10	MHz	1
H1, H2 Rise, Fall Times	t_{H1r}, t_{H1f}	5			%	3
V1, V2 Rise, Fall Times	t_{V1r}, t_{V1f}	5			%	3
V1 - V2 Cross-over	V_{VCR}	-1	0	1	V	
H1 - H2 Cross-over	V_{HCR}	2	3	5	V	
H1, H2 Setup Time	t_{HS}	5	10		μ s	
RG Clock Pulse Width	t_{RGw}	5	10		ns	4
V1, V2 Clock Pulse Width	t_{Vw}	20	20		μ s	
Pixel Period (1 Count)	t_e		250		ns	2
Readout Time	$t_{readout}$		2,533		ms	7
Integration Time	t_{int}					5
Line Time	t_{line}		0.821		ms	6

1. 50% duty cycle values.
2. CTE will degrade above the maximum frequency.
3. Relative to the pulse width (based on 50% of high/low levels).
4. RG should be clocked continuously.
5. Integration time is user specified.
6. $(3103 * t_e) + t_{HS} + (2 * t_{Vw}) = 0.821$ msec
7. $t_{readout} = t_{line} * 3086$ lines

Edge Alignment

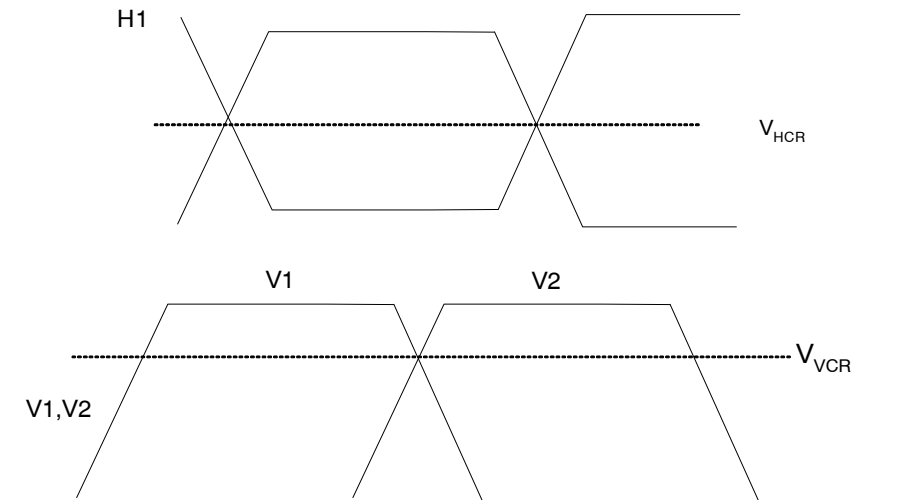


Figure 12. Timing Edge Alignment

Frame Timing

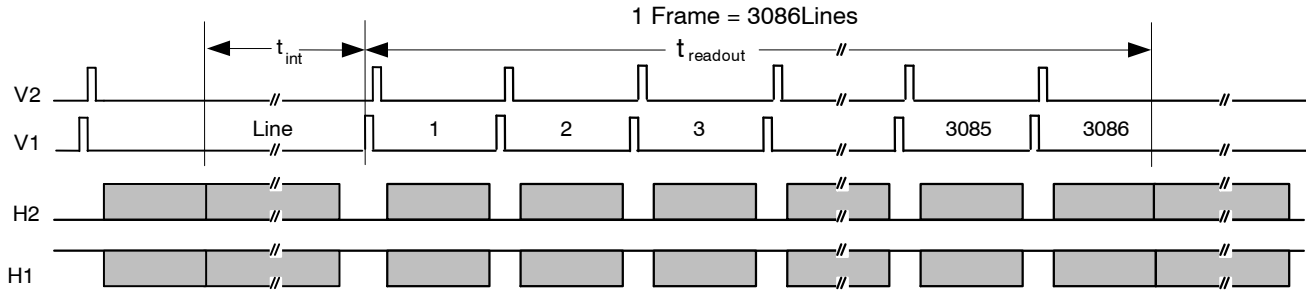


Figure 13. Frame Timing

Frame Timing Detail

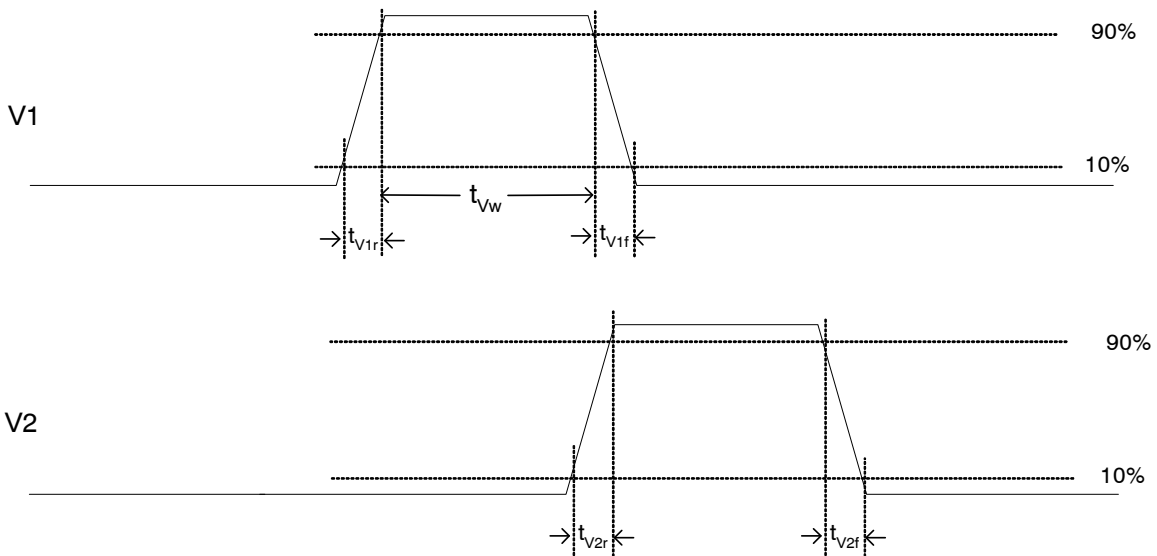


Figure 14. Frame Timing Detail

Line Timing

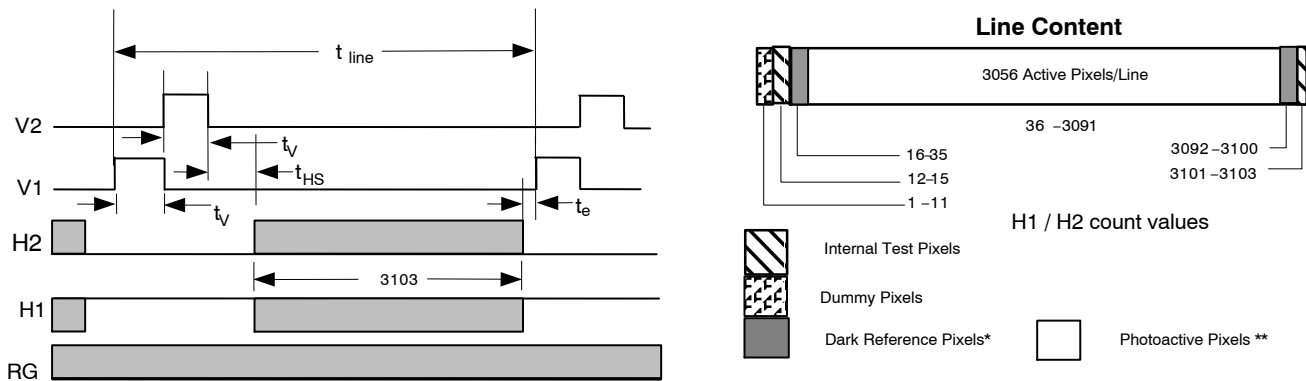


Figure 15. Line Timing

Pixel Timing

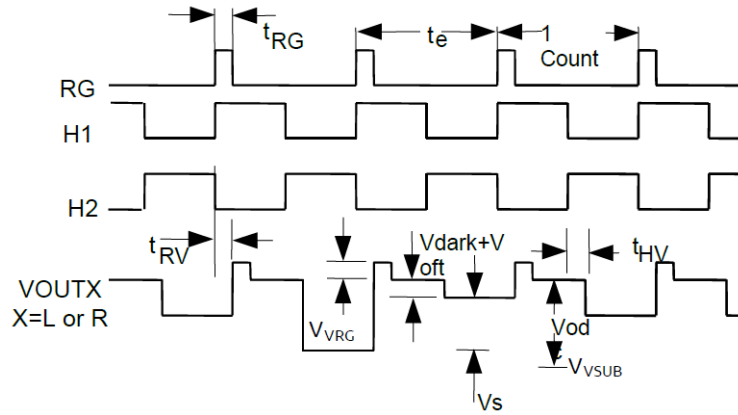


Figure 16. Pixel Timing

Pixel Timing Detail

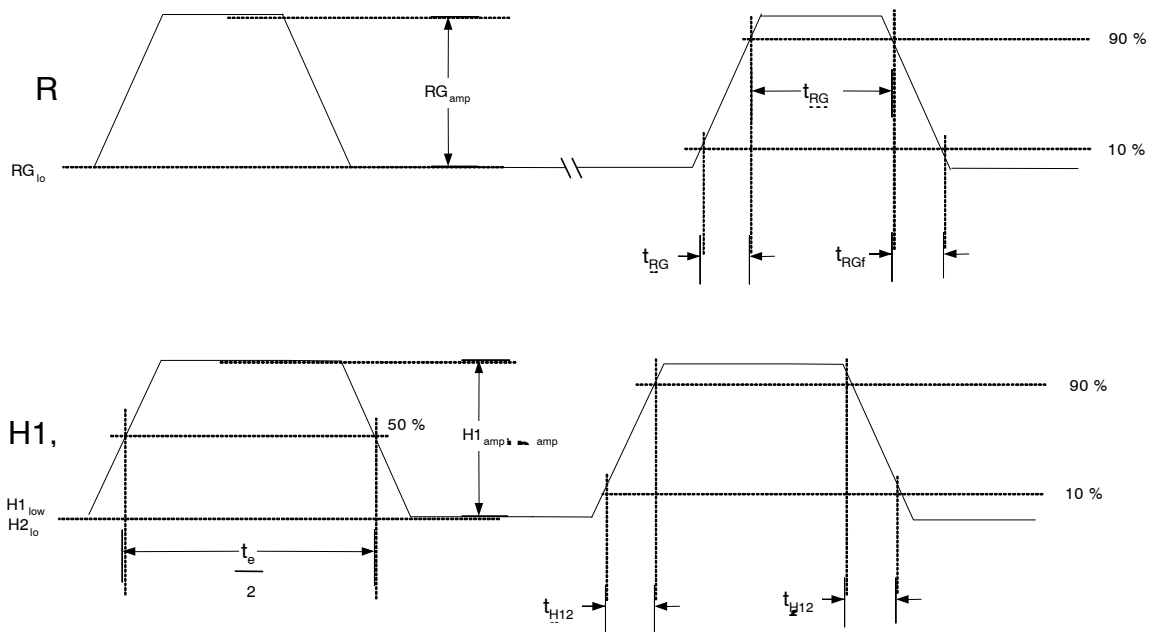


Figure 17. Pixel Timing Detail

KAF-09000

Example Waveforms

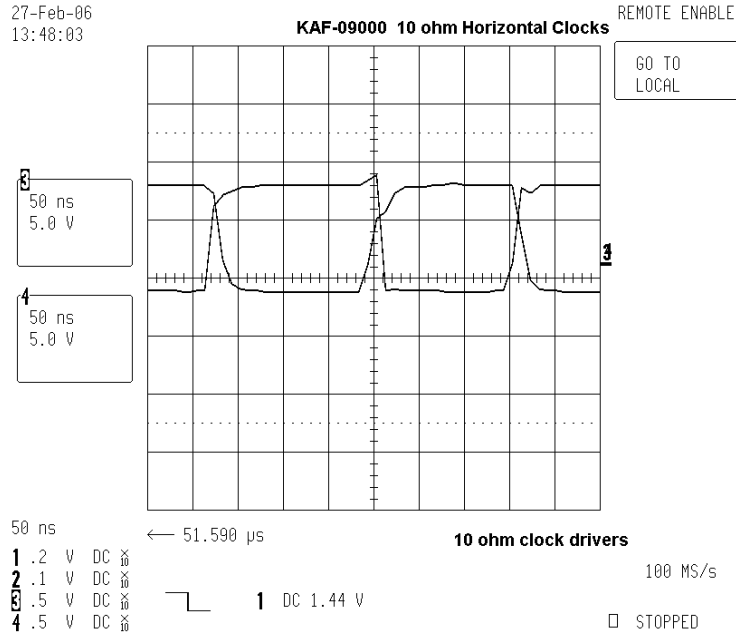


Figure 18. Horizontal Clocks

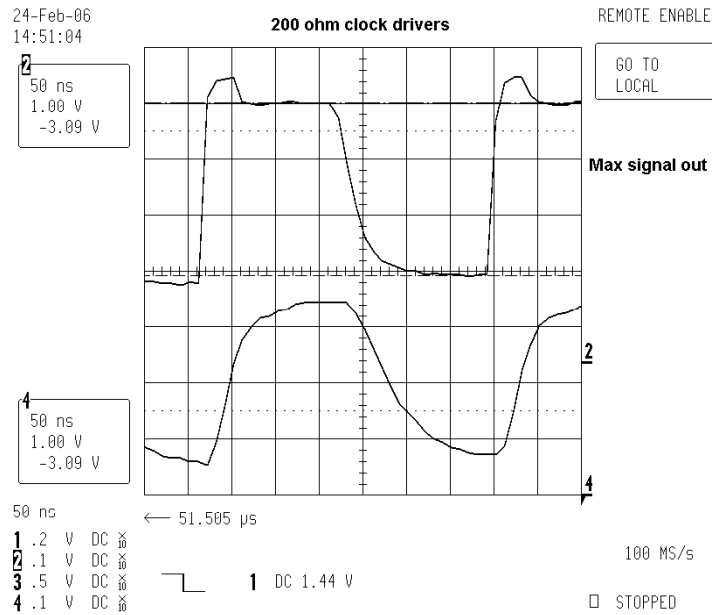


Figure 19. Video Waveform

NOTE: The upper waveform was taken at the CCD output and the lower waveform was taken at the analog to digital converter, and is bandwidth limited.

KAF-09000

27-Feb-06
14:48:09

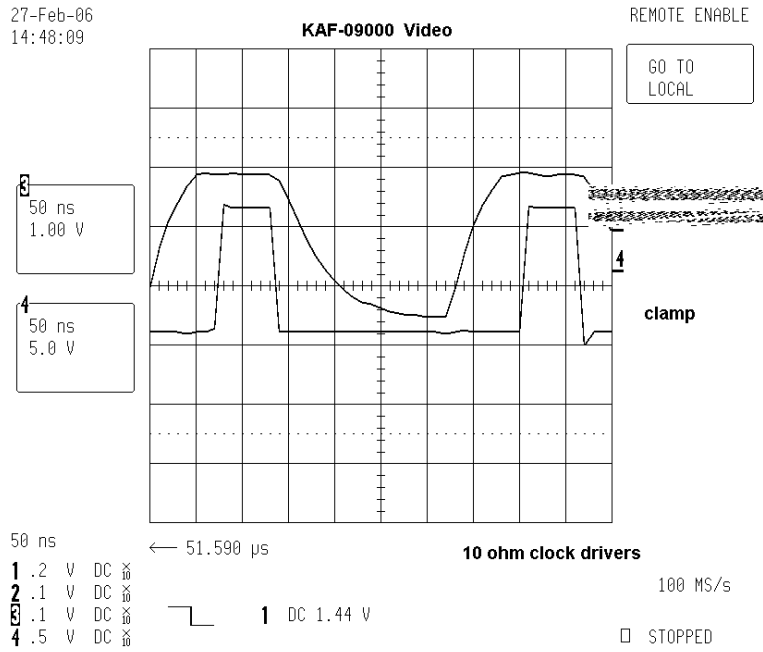


Figure 20. Video Waveform and Clamp Clock

27-Feb-06
15:09:04

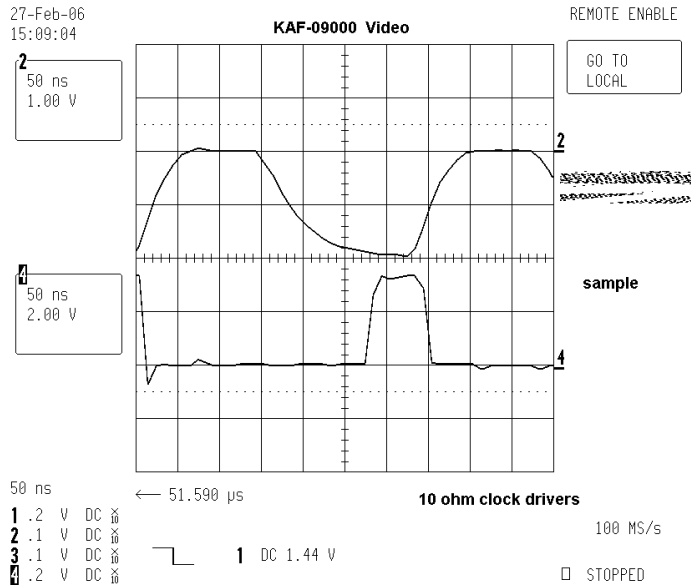


Figure 21. Video Waveform and Sample Clock

STORAGE AND HANDLING

Table 12. STORAGE CONDITIONS

Description	Symbol	Minimum	Maximum	Units	Notes
Storage Temperature	T _{ST}	-20	70	°C	1

1. Long term storage toward the maximum temperature will accelerate color filter degradation.

For information on ESD and cover glass care and cleanliness, please download the *Image Sensor Handling and Best Practices* Application Note (AN52561/D) from www.onsemi.com.

For information on soldering recommendations, please download the *Soldering and Mounting Techniques Reference Manual* (SOLDERRM/D) from www.onsemi.com.

For quality and reliability information, please download the *Quality & Reliability Handbook* (HBD851/D) from www.onsemi.com.

For information on device numbering and ordering codes, please download the *Device Nomenclature* technical note (TND310/D) from www.onsemi.com.

For information on Standard terms and Conditions of Sale, please download [Terms and Conditions](http://www.onsemi.com) from www.onsemi.com.


Cover Glass Specification

MAR Glass for Sealed Cover

1. Scratch and dig: 10 micron max
2. Substrate material Schott D263T eco or equivalent
3. Multilayer anti-reflective coating

Table 13.

Wavelength	Total Reflectance
420 – 450	2%
450 – 630	1%
630 – 680	2%

ON Semiconductor and the  are registered trademarks of Semiconductor Components Industries, LLC (SCILLC) or its subsidiaries in the United States and/or other countries. SCILLC owns the rights to a number of patents, trademarks, copyrights, trade secrets, and other intellectual property. A listing of SCILLC's product/patent coverage may be accessed at www.onsemi.com/site/pdf/Patent-Marking.pdf. SCILLC reserves the right to make changes without further notice to any products herein. SCILLC makes no warranty, representation or guarantee regarding the suitability of its products for any particular purpose, nor does SCILLC assume any liability arising out of the application or use of any product or circuit, and specifically disclaims any and all liability, including without limitation special, consequential or incidental damages. "Typical" parameters which may be provided in SCILLC data sheets and/or specifications can and do vary in different applications and actual performance may vary over time. All operating parameters, including "Typicals" must be validated for each customer application by customer's technical experts. SCILLC does not convey any license under its patent rights nor the rights of others. SCILLC products are not designed, intended, or authorized for use as components in systems intended for surgical implant into the body, or other applications intended to support or sustain life, or for any other application in which the failure of the SCILLC product could create a situation where personal injury or death may occur. Should Buyer purchase or use SCILLC products for any such unintended or unauthorized application, Buyer shall indemnify and hold SCILLC and its officers, employees, subsidiaries, affiliates, and distributors harmless against all claims, costs, damages, and expenses, and reasonable attorney fees arising out of, directly or indirectly, any claim of personal injury or death associated with such unintended or unauthorized use, even if such claim alleges that SCILLC was negligent regarding the design or manufacture of the part. SCILLC is an Equal Opportunity/Affirmative Action Employer. This literature is subject to all applicable copyright laws and is not for resale in any manner.

PUBLICATION ORDERING INFORMATION

LITERATURE FULFILLMENT:

Literature Distribution Center for ON Semiconductor
 P.O. Box 5163, Denver, Colorado 80217 USA
Phone: 303-675-2175 or 800-344-3860 Toll Free USA/Canada
Fax: 303-675-2176 or 800-344-3867 Toll Free USA/Canada
Email: orderlit@onsemi.com

N. American Technical Support: 800-282-9855 Toll Free
 USA/Canada
Europe, Middle East and Africa Technical Support:
 Phone: 421 33 790 2910
Japan Customer Focus Center
 Phone: 81-3-5817-1050

ON Semiconductor Website: www.onsemi.com
Order Literature: <http://www.onsemi.com/orderlit>
 For additional information, please contact your local
 Sales Representative



Стандарт Электрон Связь

Мы молодая и активно развивающаяся компания в области поставок электронных компонентов. Мы поставляем электронные компоненты отечественного и импортного производства напрямую от производителей и с крупнейших складов мира.

Благодаря сотрудничеству с мировыми поставщиками мы осуществляем комплексные и плановые поставки широчайшего спектра электронных компонентов.

Собственная эффективная логистика и склад в обеспечивает надежную поставку продукции в точно указанные сроки по всей России.

Мы осуществляем техническую поддержку нашим клиентам и предпродажную проверку качества продукции. На все поставляемые продукты мы предоставляем гарантию .

Осуществляем поставки продукции под контролем ВП МО РФ на предприятия военно-промышленного комплекса России , а также работаем в рамках 275 ФЗ с открытием отдельных счетов в уполномоченном банке. Система менеджмента качества компании соответствует требованиям ГОСТ ISO 9001.

Минимальные сроки поставки, гибкие цены, неограниченный ассортимент и индивидуальный подход к клиентам являются основой для выстраивания долгосрочного и эффективного сотрудничества с предприятиями радиоэлектронной промышленности, предприятиями ВПК и научно-исследовательскими институтами России.

С нами вы становитесь еще успешнее!

Наши контакты:

Телефон: +7 812 627 14 35

Электронная почта: sales@st-electron.ru

Адрес: 198099, Санкт-Петербург,
Промышленная ул, дом № 19, литера Н,
помещение 100-Н Офис 331